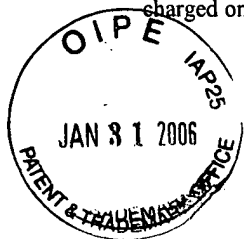


Any fee due as a result of this paper, not covered by an enclosed check, may be charged on Deposit Acct. No. 50-1290.



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By: Patricia Muir  
Patricia Muir

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Inventor: Hiroshi OKUMURA  
Serial No.: 10/615,670  
Filed: July 8, 2003  
Title: **METHOD OF FORMING SEMICONDUCTOR THIN-FILM  
AND LASER APPARATUS USED THEREFORE**  
Examiner: Samuel M. Heinrich  
Group Art Unit: 1725  
Confirmation No.: 9827  
Attorney Docket No.: 100806-00215 (NECA 20.494)

January 31, 2006

Mail Stop AF  
Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT**

S I R :

In response to the Office Action mailed on August 1, 2005, please amend the above-captioned application as follows: